

DEPARTMENT OF THE NAVY NAVAL UNDERSEA WARFARE CENTER DIVISION NEWPORT OFFICE OF COUNSEL PHONE: 401 832-3653 FAX: 401 832-4432 DSN: 432-3653



Attorney Docket No. 97968 Date: 2 September 2010

The below identified patent application is available for licensing. Requests for information should be addressed to:

TECHNOLOGY PARTNERSHIP ENTERPRISE OFFICE NAVAL UNDERSEA WARFARE CENTER 1176 HOWELL ST. CODE 07TP, BLDG. 990 NEWPORT, RI 02841

Serial Number 12/844,290

- Filing Date 27 July 2010
- Inventor Kim C. Benjamin

Address any questions concerning this matter to the Office of Technology Transfer at (401) 832-1511.

DISTRIBUTION STATEMENT Approved for Public Release Distribution is unlimited

20100908161

Attorney Docket No. 97968

DENSE TRANSDUCER ARRAY AND METHOD

STATEMENT OF GOVERNMENT INTEREST

[0001] The invention described herein may be manufactured and used by or for the Government of the United States of America for governmental purposes without the payment of any royalties thereon or there for.

CROSS REFERENCE TO OTHER PATENT APPLICATIONS

BACKGROUND OF THE INVENTION

(1) Field of the Invention

[0003] The present invention relates to a dense transducer array that provides an acoustic transducer having relatively high operational bandwidth. More particularly, the present invention includes a cable harness component that efficiently provides and organizes numerous conductors within piezocomposite substrates to form transducer arrays with minimum impact on electroacoustic performance.

(2) Description of the Prior Art

[0004] Several underwater sonar applications exist for high frequency wideband transducer arrays having individual elements such as described in U.S. Patent 6,255,761 ('761) and herein

incorporated by reference. In order to form and steer acoustic beams with an array of individual elements, the array elements must be spaced not more than one-half the acoustic wavelength at the highest frequency of interest. This implies, for squareshaped elements at least, that the elements' lateral dimensions are inversely proportional to frequency. Therefore, for fully populated radiating apertures, the number of elements increases exponentially as the spacing decreases.

[0005] As piezocomposite arrays, such as described in previously mentioned U.S. Patent '761, move to higher operational bandwidths and frequencies, the element center to center spacing decreases as the number of elements forming the array aperture increases. The result is a need for a component that organizes the numerous electrical wires found in piezocomposite arrays. [0006] U.S. Patent '761 teaches that piezoceramic transducer arrays can be formed from a block of piezoceramic material. A piezoceramic transducer preform can be created by machining away material between preform posts and leaving a base portion of the piezoceramic material on a bottom side of the block and preform posts on a top side of the block. A generalized top surface is defined by the tops of the preform posts opposite from the surface defined by the base. Conductors are inserted in the gaps between the preform posts with the ends of the conductors extending through apertures formed in the base and beyond the

general top surface of the preform posts. The combined base, preform post and conductor volume is filled with a liquid polymer which is allowed to harden. Any conductor or polymer extending above the general top surface is removed. The base and conductors extending beyond a selected transducer volume are removed leaving a bottom preform surface. Electrodes are provided on the top preform surface and the bottom preform surface. These electrodes can join with the conductor ends or can be connected to the conductor ends by known methods. This gives a flexible transducer array that can be used for a variety of applications.

SUMMARY OF THE INVENTION

[0007] Accordingly, it is an object of the present invention to provide a transducer array having densely packed transducer elements.

[0008] A second object is providing an array having mechanical isolation between array elements.

[0009] It is another object of the present invention to provide a transducer array that handles large numbers of conductors and distributes them in a two-dimensional lattice efficiently in a space-wise fashion. [0010] A further object of the present invention is to provide a transducer array having mechanical isolation between array elements.

[0011] Furthermore, it is an object of the present invention to provide a transducer array that supports transmit operation as well as receive operation, while at the same time having cabling that is robust enough to handle high drive signals.

[0012] Yet another object is providing a transducer array having a plurality of closely spaced elements capable of transmitting and receiving acoustic signals at high frequencies.

[0013] Still another object is providing a method of making a transducer array having closely spaced transducer elements. [0014] Other objects and advantages of the present invention will become more obvious hereinafter with regard to the disclosure contained in the specification and drawings. [0015] Accordingly, there is provided a cable harness component that is particularly suited for transducer arrays. The cable harness component includes a support structure having a plurality of predetermined openings made from a viscoelastic material. A plurality of flexible circuits having conductors communicates between terminal blocks and electrical contacts within the support structure. Terminal blocks are positioned for outside electrical connection.

[0016] A cable harness component for a transducer array includes a support structure having a plurality of predetermined openings therein for accommodating transducer components. Flexible circuits are embedded in the support structure. Each flexible circuit has first ends being positioned in the support structure predetermined openings. Terminal blocks are joined to the second ends.

[0017] A transducer array assembly includes a support structure having a plurality of predetermined openings therein for accommodating transducer components. Flexible circuits are embedded in the support structure. Each flexible circuit has first ends being positioned in the support structure predetermined openings. Terminal blocks are joined to the second ends. Transducer elements are positioned in the support structure predetermined openings and placed in electrical communication with the flexible circuit first ends. A polymer material is provided surrounding the transducer elements, said support structure, and said flexible circuit first ends. There is also provided a method for manufacturing the transducer array.

BRIEF DESCRIPTION OF THE DRAWINGS

[0018] Other objects, features and advantages of the present invention will become apparent upon reference to the following description of the preferred embodiments and to the drawings,

wherein corresponding reference characters indicate corresponding parts throughout the several views of the drawings and wherein:

[0019] FIG. 1 is a side view of the cable harness component according to one embodiment of the present invention; [0020] FIG. 2 is a top view illustrating the mating of the cable

harness component with a transducer array ;

[0021] FIG. 3A is an expanded view of a portion of FIG. 2 before polymer has been added to the assembly;

[0022] FIG. 3B is an expanded view of a portion of FIG. 2 after polymer has been added to the assembly, and the excess has been removed;

[0023] FIG. 3C is an expanded view of a portion of FIG. 2 after electrodes have been provided on the assembly; and [0024] FIG. 4 illustrates a finished transducer array.

DETAILED DESCRIPTION OF THE INVENTION

[0025] Referring now to the drawings, and more particularly to FIG. 1, there is shown the cable harness component 10 that includes a plurality of flexible circuits 12. Flexible circuits 12 are embedded within a support structure 14 and are terminated by conventional connector terminal blocks 16. The flexible circuits 12 have a plurality of flex-circuit ends that can connect the flexible circuits 12 to electrical contacts on the

transducer material that is to be further described hereinafter with reference to FIG. 3. In FIG. 3, two specific flex-circuit ends are identified as 12A and 12B. The support structure 14 can be made of any material having the required vibration damping characteristics. Preferably, it is made of a viscoelastic material, known in the art. Support structure 14 has a plurality of openings 14A that will be further described with reference to FIG. 2.

[0026] In general, the cable harness component 10 comprises the support structure 14 having a plurality of predetermined openings 14A and comprised of a viscoelastic material. The plurality of flexible circuits 12 each have first and second opposite ends with each end having connecting means. The plurality of flexible circuits 12 are embedded in the support structure 14. The plurality of terminal blocks 16 each have first and second connecting means. The plurality of flexible circuits 12 and the plurality of terminal blocks 16 are preferably of an equal number and with the connecting means of the first opposite ends of the flexible circuits being connected to corresponding first connecting means of the terminal blocks 16. The second connecting means of the terminal blocks 16 are preferably made available for connecting to external equipment. [0027] With reference to FIG. 1, it is seen that the cable harness component 10 has its support structure 14, its plurality

of flexible circuits 12, and its terminal blocks 16 arranged in an opened three face assembly with the terminal blocks 16 and support structure 14 being arranged parallel to and facing each other and are spaced apart by about the horizontal height 20 of the flexible circuits 12.

[0028] The flexible circuits 12 are selected so as to have three sides with the first side having a length 22 to accommodate mating with the terminal blocks 16, the second side of the flexible circuits 12 has a length 24 to accommodate mating with the support structure 14, and the third side having a length so as to space apart the support structure 14 and terminal block 16 and corresponds to about the horizontal height 20 of the flexible circuits 12.

[0029] With reference to FIG. 2, it is seen that the cable harness component 10 is particularly suited to be selected for mating with a transducer array. Transducer array can be formed from a preform 18 of piezoceramic material. This is more fully described above and in the previously incorporated by reference U.S. Patent 6,255,761 ('761). The preform 18 comprises a plurality of posts 26A, 26B ... 26n joined to a base 28. In this embodiment, four typical posts, 26A, 26B, 26C and 26D, are positioned in a single support structure opening 14A to form an array element. Each of the posts 26A...26n represents an electromechanical unit. Openings 14A of the support structure

14 correspond and accommodate the insertion of one or more of the posts. Different embodiments of the invention can incorporate different numbers of posts. The number and lateral spacing of posts can be chosen according to the desired application.

[0030] The cable harness component 10 provides electrical connection for the posts 26, as well as electromechanical isolation, so that signals present in one portion of post or group of posts 26 do not affect another portion of posts 26. The interconnection of the cable harness component 10 to external equipment (not shown) may be accomplished via terminal blocks 16 which, in turn, are connected to appropriate cabling related to associated external equipment. The interconnection between the cable harness component 10 and the posts 26 may be further described with reference to FIG. 3A.

[0031] FIG. 3A illustrates further details of the interconnections between the cable harness component 10 of FIG. 1 of the present invention and posts 26 of FIG. 2. More particularly, FIG. 3A is an expanded view of a portion of the interconnections between the cable harness component 10 and posts 26 for one typical embodiment of the present invention. Further, for the illustration of FIG. 3A, the flexible circuits 12 are not shown, but are present under and embedded within the support structure 14.

[0032] FIG. 3A illustrates a plurality of connecting means 12A and 12B. These are the ends of flexible circuit 12 conductors. In FIG. 3A directions are indicated by arrows 30 and 32. The flexible circuits 12 within the support structure 14, not shown in FIG. 3A, are arranged so as to run under the support structure 14, and are oriented along one direction 30 with like surfaces running parallel to each other. In direction 32 perpendicular to direction 30, the cable harness/isolator 10, in particular to support structure 14, does not have any embedded flexible circuits 12.

[0033] Ends of flexible circuit conductors, identified for one set as connections 12A and 12B are dimensioned and formed so that connection 12A exits out from the associated flexible circuit 12 upward and out of the associated chamber 14A, while connection 12B exits out from the associated flexible circuit 12 downward and out of the associated chamber 14A. The 12A connection located above the upper surface of the associated posts 26 is available for positive electrical connection to an associated electrode element, while the 12B connection located below the lower surface of the associated posts 26 is available for negative electrical or ground connection to an associated electrode element.

[0034] Cable harness 10 can be joined to a preform by the following method. Flexible circuits 12 are positioned within

support structure 14 so that flexible circuit ends, as typically shown at 12A, are positioned to extend into an opening 14A. The other end of flexible circuit 12 is joined to an electrical connector 16. A ceramic array component, as detailed in U.S. Patent '761, is available as a preform 18 having posts 26 joined to a base 28. Preform 18 is positioned within support structure 14 such that four posts 26 extend into each opening 14A. Of course, in other embodiments openings 14A can support different numbers of posts. Flexible circuit ends having a first electrical polarity 12A are positioned to extend out of each opening 14A, and flexible circuit ends having a second electrical polarity 12B are positioned to extend proximate the base 28 of the preform 18. In other embodiments, base 28 can have apertures formed therein for receiving flexible circuit ends 12B.

[0035] FIG. 3B shows the next step in creating a transducer array. A settable polymer 34 is provided around support structure 14 and within openings 14A to retain posts 26 and flexible circuit ends 12A and 12B in position within openings 14A and base apertures. After the settable polymer hardens, excess polymer 34, flexible circuit ends 12A and 12B and the ceramic array component base 28 are removed by machining. Upon removal of the polymer and base, a top surface and a bottom surface of the posts 26 are exposed. On the exposed surface

shown in FIG. 3B, circuit end 12A is shown among post tops 36. Polymer 34 covers support structure 14. The bottom surface looks generally the same as the top surface.

[0036] As shown in FIG. 3C, electrodes 38 can be deposed on the top and bottom surfaces. Post tops 36 and circuit end 12A are shown with hidden lines. Electrode 38 electrically connects a selected number of post tops 36 with circuit end 12A. In this embodiment four post tops 36 are joined to a single circuit end 12A to form an array element. Electrodes 38 can be formed by providing a conductive coating on top of circuit ends 12A and post surfaces 36 by any number of methods known in the art. The conductive coating forms an electrode having a first polarity on post surfaces 36 and an electrode having a second polarity on the bottom of the posts (not shown). These electrodes 38 can be formed in contact with flexible circuit end such that flexible circuit end having a first electrical polarity is in electrical communication with the electrode having a first polarity on the top of the preform. Likewise, flexible circuit end having a second electrical polarity is in electrical communication with the electrode having a second polarity on the bottom of the post. As shown, multiple posts can be electrically joined by a single electrode to a single flexible circuit end. This process allows thermoforming the ceramic preform 18 substrate and organizes the numerous conductors making up the large number of

array elements, such as the four posts 26, forming such an array element.

[0037] This can be performed by other methods such as by providing contacts on circuit sheets mounted to the top surface of array and to the bottom surface of array. A polymer coating can be provided outside the electrical components to shield them from the environment.

[0038] After the electrodes are formed, the array can be curved forming a finished transducer array 40, shown in FIG. 4. This array 40 includes a plurality of transducer elements indicated by electrode 38 embedded in a polymeric elastomer 34, known in the art. Array 40 can be prepared for use by covering it with an acoustically transparent coating and providing it on a resilient mounting. Flexible circuits 12 would likely extend into an interior of a structure.

[0039] It should now be appreciated that the practice of the present invention provides a cable harness/isolator 10 that can be used to form an array of acoustic transducer elements by installing it over a piezoelectric preform 18 that consists of individual ceramic posts 26, backfilling the formed substrate of arrays with polymer, and grinding the upper and lower surfaces of the substrate flat and parallel to each other.

[0040] It should be further appreciated that the practice of the present invention allows for handling a relatively large number

of conductors entering the terminal blocks 16 and leaving the flexible circuits 12 so as to be, in one embodiment, distributed in a two-dimensional lattice efficiently in a space-wise fashion.

[0041] Further, it should be appreciated that the practice of the present invention provides mechanical isolation between array elements 26 deemed critical, by those skilled in the art, for wideband, high frequency grating-lobe free beam steering. The mechanical isolation is provided by the physical spacing between elements 26 and also the support structure 14 material. [0042] Further still, it should be appreciated that the mated assembly comprising the cable harness component 10 and the PZT ceramic preform 18 supports transmit operation, as well as receive operation, while at the same time those skilled in the art may provide cabling made robust enough to handle high drive signals.

[0043] Still further, it should be appreciated that the practice of the present invention by those skilled in the art following the bending and curving principles of U.S. Patent 6,255,761 and applying those principles to the embodiments described with reference to FIGS. 1-4 allows electrode substrate to be singly curved for conformal array fabrication.

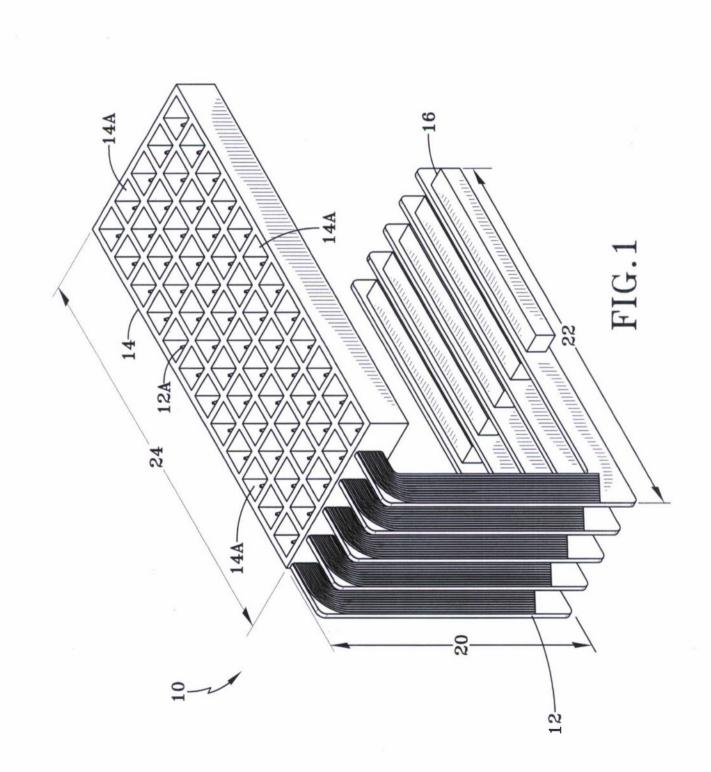
[0044] It will be understood that many additional changes in the details, materials, steps and arrangement of parts, which have

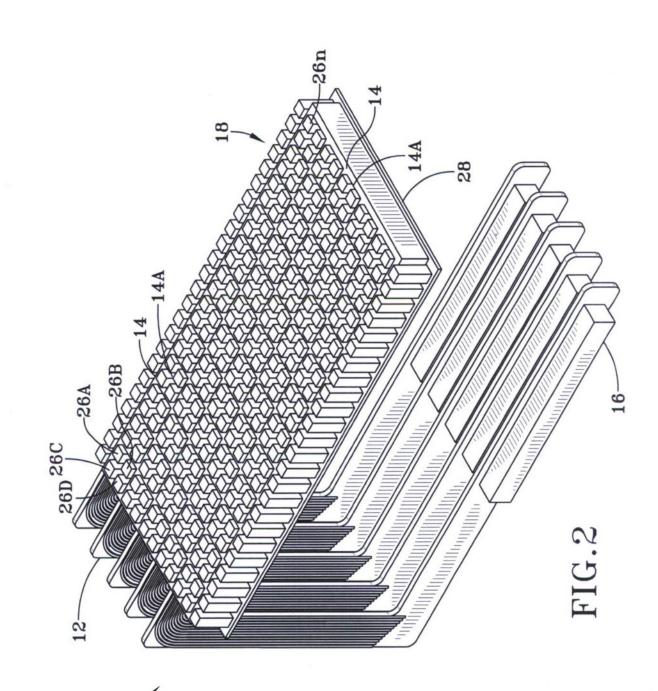
been herein described and illustrated in order to explain the nature of the invention, may be made by those skilled in the art within the principle and scope of the expressed in the appended claims. Attorney Docket No. 97968

DENSE TRANSDUCER ARRAY AND METHOD

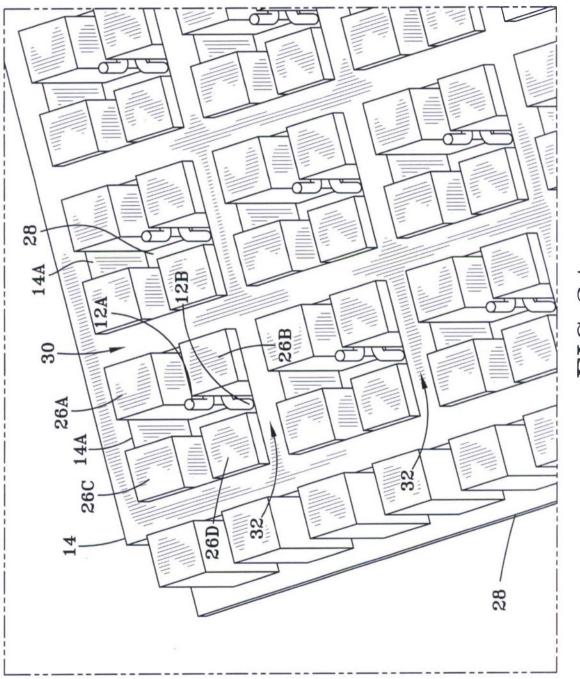
ABSTRACT OF THE DISCLOSURE

A transducer array assembly includes a support structure having a plurality of predetermined openings therein for accommodating transducer components. Flexible circuits are embedded in the support structure. Each flexible circuit has first ends being positioned in the support structure predetermined openings. Terminal blocks are joined to the second ends. Transducer elements are positioned in the support structure predetermined openings and placed in electrical communication with the flexible circuit first ends. A polymer material is provided surrounding the transducer elements, said support structure, and said flexible circuit first ends. There is also provided a method for manufacturing the transducer array.

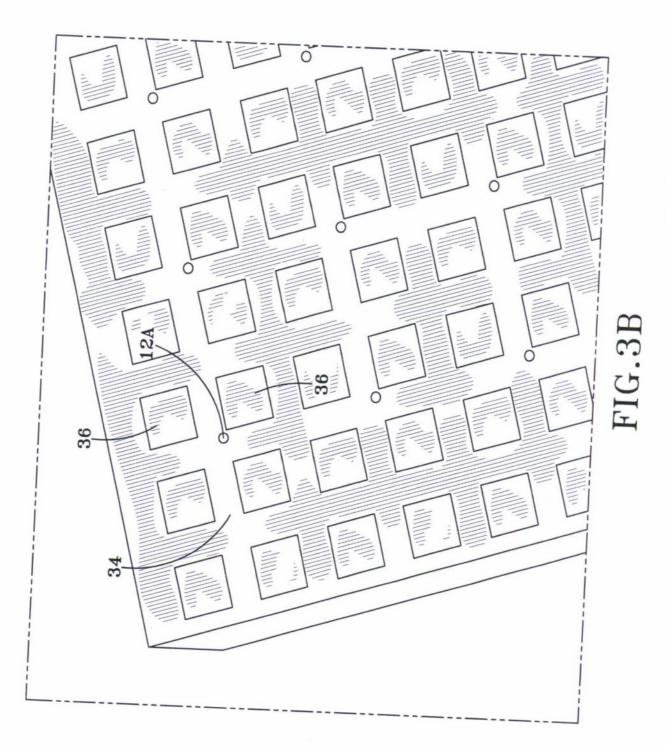


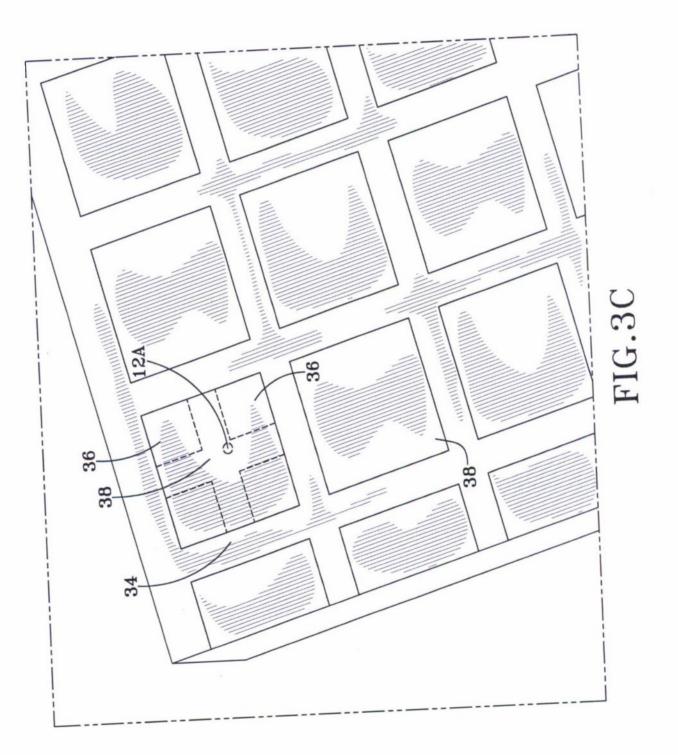


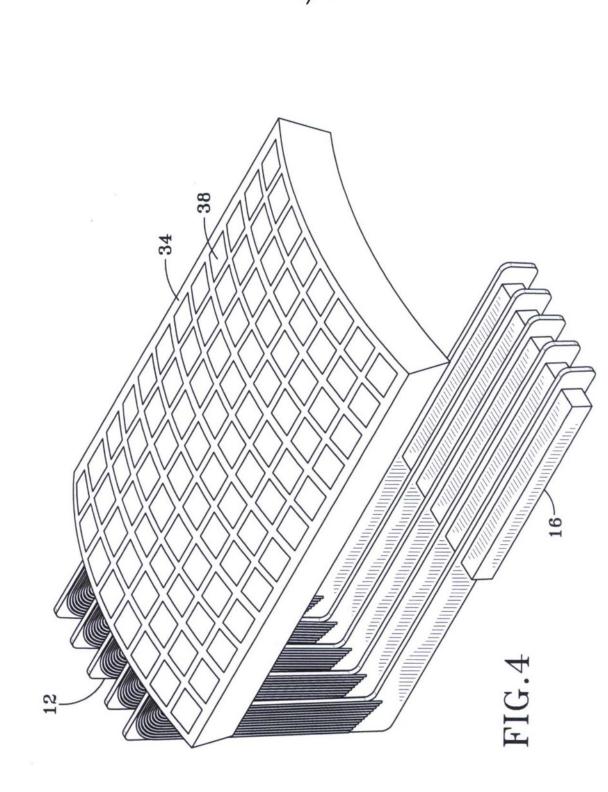
10











6/6

40